





Application/Control No.	Applicant(s)/Patent under Reexamination
10/760,300	CHEN ET AL.
Examiner	Art Unit
Shantell Portis	2617

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
See Attached	7/27/2006	SLP	
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